



**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q63956

Toshiaki KUNIYASU, et al.

Appln. No.: 09/826,851

Group Art Unit: 2828

Confirmation No.: 3185

Examiner: James Menefee

Filed: April 6, 2001

For: SEMICONDUCTOR LASER ELEMENT AND SEMICONDUCTOR LASER

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action dated September 10, 2002, Applicant hereby elects the claims of Group I, including claims 1-7 and 18-21. This election with made without traverse.

Timely and favorable consideration on the merits is respectfully requested.

Respectfully submitted,

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Date: October 10, 2002

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**PRELIMINARY AMENDMENT**

Commissioner for Patents  
Washington, D.C. 20231

Sir:

Prior to examination on the merits, please amend the above-identified application as follows:

**IN THE CLAIMS:**

✓ Please cancel claim 22 without prejudice or disclaimer.

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